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Docket No.: 8734.231.00
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Sang-Hyun KIM

Confirmation No. 9240

Application No.: 10/661,486

Art Unit: 2813

Filed: September 15, 2003

Examiner: Laura M. Schillinger

For: METHOD OF FABRICATING
POLYCRYSTALLINE SILICON THIN FILM
FOR IMPROVING CRYSTALLIZATION
CHARACTERISTICS AND METHOD OF
FABRICATING LIQUID CRYSTAL DISPLAY
DEVICE USING THE SAME

Customer No.: 30827

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Non-Final Office Action dated June 28, 2005 Applicant hereby requests entry of the following amendments.

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.